Dynamic Switching Characteristics of 1 A Forward Current β-Ga2O3 Rectifiers

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Abstract—An inductive load test circuit was used to measure the switching performance of field-plated edge-terminated Schottky rectifiers with a reverse breakdown voltage of 760 V (0.1 cm diameter, 7.85 × 10² cm² area) and an absolute forward current of 1 A on 8 µm thick epitaxial β-Ga2O3 drift layers. The recovery characteristics for these vertical geometry β-Ga2O3 Schottky rectifiers switching from forward current of 1 A to reverse off-state voltage of -300 V showed a recovery time (trr) of 64 ns. There was no significant temperature dependence of trr up to 150°C.

Index Terms—Gallium Oxide, Schottky diode, rectifiers

I. INTRODUCTION

There is strong interest in the application of wide-bandgap semiconductors to power device applications to overcome the limitations of Si with respect to blocking voltage, maximum operating temperature and switching frequency. Improved power efficiency and densities are achieved with commercially available SiC (bandgap 3.3 eV) and GaN (bandgap 3.4 eV) rectifiers in switching and control applications [1-3]. Recently, β-Ga2O3, with its even higher theoretical power figure-of-merit, has attracted attention for achieving even higher blocking voltages and lower on-resistance due to its higher band gap of 4.8 eV, which corresponds to a ~8 MV/cm theoretical breakdown electric field [4-20]. Reverse breakdown voltages larger than 1 kV were reported for both unterminated Ga2O3 vertical rectifiers (1000-1600 V) and field-plated Schottky diodes (1076-2300 V) with an epi thickness of 8-20 µm[10-12,14,19] Furthermore, the switching characteristics of discrete Ga2O3 vertical Schottky rectifiers were also investigated, and the recovery time was in the range of 20 to 30 ns [10,12,13]. Joishi et al.[20] reported field-plate bevel mesa Schottky diodes using LPCVD-grown β-Ga2O3 epi layers. The devices had maximum reverse breakdown of 190V, corresponding to a breakdown field of 4.2MV.cm⁻¹, with an extrinsic R_on of 3.9 mΩ·cm². The absence of clear demonstrations of p-type doping in Ga2O3, which may be a fundamental issue resulting from the band structure, makes it difficult to simultaneously achieve low turn-on voltages and ultra-high breakdown because of the absence of a p-i-n rectifier technology.

Mixed-mode circuit simulations of Ga2O3 power MOSFETs have shown lower conduction loss and higher switching loss than commercial SiC MOSFETs in a three phase modular multilevel converter [21,22]. Experimental measurements of Ga2O3 device switching performance are needed to optimize design and reducing switching loss. He et al. [23] evaluated dynamic behavior of 200V breakdown Ga2O3 diodes for switching operations induced by half-wave rectification (100 kHz) in an AC-DC converter circuit and found performance comparable to SiC [24]. It is clear that the performance of Ga2O3 rectifiers is improving rapidly [17], but more work is needed for high current switching conditions. Takatsu et al.[25] reported the recovery characteristics of β-Ga2O3 trench MOS Schottky barrier diodes with chip size 0.9 × 0.9 mm², active region diameter 0.3 mm, specific on-resistance Ron of 3.09 mΩ·cm² and breakdown voltage 300 V. They obtained reverse recovery times of order 7 ns for switching from 1A forward current to -100 V reverse voltage, faster than Si or SiC diodes [25].

In this letter, we report the temperature dependence of reverse recovery times of larger area, 1A Ga2O3 field-plated rectifiers fabricated on 8 µm epitaxial layers on bulk conducting substrates using an inductive load test circuit. We demonstrate that these devices switched from 1A forward current to -300V reverse bias exhibit high switching speed and low loss recovery characteristics.

II. EXPERIMENTAL

Drift layers of Si doped n-type Ga2O3 with epitaxial layer

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thickness 8 µm were grown by Halide Vapor Epitaxy (HVPE) on β-phase Sn-doped Ga2O3 single crystal wafers with (001) surface orientation. These bulk wafers were grown by the edge-defined film-fed method with a carrier concentration of $3.6 \times 10^{18}$ cm$^{-3}$. The field-plated, edge terminated (FPET) vertical rectifier fabrication started with full back-side Ti/Au Ohmic contacts, followed by rapid thermal annealing under N$_2$ at 550°C for 30 sec [14,15]. A combination of SiO$_2$/SiNx dielectric layers (40/360 nm) were deposited using plasma enhanced chemical vapor deposition. Different size dielectric windows were etched with 1:10 buffered oxide etch (BOE). Ni/Au Schottky contacts (thickness 80 nm/420 nm) were deposited on the dielectric windows with 10µm overlap with the SiO$_2$/SiNx dielectric layer. The diameter of the circular contact was 0.1 cm (area $7.85 \times 10^{-3}$ cm$^2$). Figure 1 shows the cross-sectional schematic of the rectifier. Diode DC characteristics were carried out with an Agilent 4156C parameter analyzer for current and voltage level up to 100 mA and 100 V, respectively. For high voltage and current DC measurements, a Tektronix 370A curve tracer was used. A current probe along with a Micsig (DP10013) differential probe was used for the diode switching characteristic measurements.

To measure the response of the diode’s recovery time, a clamped inductive load test circuit was designed and fabricated for the switching measurement [21,22], Figure 2. The circuit operations are also illustrated. During the switching operation, a double pulse was employed to drive the Si transistor, and the duration of the duty cycle was used to adjust the Ga$_2$O$_3$ current through the diode becomes zero. The schematic of the reverse recovery output represents that direction of the current flow under different pulse period for the circuit board. Both indenter and Si MOSFET were purchased from Mouser Electronics. The indenter that was used for this circuit has inductance of 15 mH with maximum DC current of 1.3 A. The model number for Si MOSFET is STW9N150 with 1500 V of drain-source breakdown, 8 A of continuous drain current, and 2.5 Ω drain-source resistance. There was no simulation on the actual device reverse recovery characteristics for this study. A photo of the entire test set-up is shown in Figure 3.

**RESULTS AND DISCUSSION**

Figure 4 shows the single-sweep forward and reverse current density (J-V) characteristics for the rectifier. The breakdown voltage ($V_{br}$) was 760 V, with 1A of forward current at ~2.3V. The current density for this 1 A device is in the range of 127 A/cm$^2$, which is lower than the smaller devices on this sample. We believe that this is mainly due to the spreading resistance of our Schottky contact for a larger device size. The Schottky diode forward current. First, the inductor was charged from the DC power supply when the transistor was turned on (accumulation mode). When the transistor was turned off, the pre-charged inductor released charge through the forward-biased diode (circularizing mode). As the transistor turned on again, the Schottky diode was switched from the on- to the off-state, where the charge in the diode was depleted. Finally, the leakage current at lower reverse voltage is a result of the measurement limitation of the curve tracer of around 10 nA resolution. The thermionic emission model was used to obtain Schottky barrier height and ideality factor of 1.05 eV and 1.08, respectively. The carrier concentration was obtained as 4.36x10$^{15}$ cm$^{-3}$ from C-V characteristics. The on-state...
resistance, $R_{ON}$, was 22.2 mΩ cm$^2$, leading to a power figure of merit ($V_B^2 / R_{ON}$) of 26 MW cm$^2$. The diode on-off ratio was in the range $2.7 \times 10^2$-$2.2 \times 10^9$ over our measurement range.

Figure 5 shows reverse recovery switching characteristics for a single device switching from 10 V to -35 V, with reverse recovery time, $\tau_{rr}$, of 11 nsec. This was defined as the time taken for rectifiers to recover to the current level of 25% of the reverse recovery current, $I_{rr}$. The reason for selecting 10 V is to get a forward current to be higher than 100 mA. Device size is 0.6 mm x 0.6 mm. This measurement shows intrinsic switching of the device without loading from a test circuit.

Figure 6 shows the switching performance and voltage waveform for the switching node of 1 A forward current/760 V rectifier. The device was switched from 1 A forward current to a reverse voltage of -300 V. The circuit was operated with a period of 100µsec, duty cycle 4%, MOSFET pulse was 10 V and the power supply for the rectifier was 300 V. The recovery time was 64 ns with $I_{rr}$ of 0.82 A, and the $dI/dt$ was 24.7 A/µs. The rectifier has a recovery time of ~11 ns - the additional recovery time comes from parasitics on the PCB board.

There is also interest in the switching performance at elevated temperatures since uncooled operation would be an attribute of wide bandgap power switching systems. Figure 7 illustrates the effect of temperature on $\tau_{rr}$ for switching from 1 A forward current to -200 V reverse bias. The $\tau_{rr}$ varied from 48 to 50 ns for 25 to 125°C. These are similar to the previous results reported for switching at much lower voltages (4 V to 10 V) [23]. There was no significant effect of either off state voltage or on-state current, a result of the short minority carrier lifetime of $\beta$-Ga$_2$O$_3$, as shown in Fig. 8. Lee et al. [26] reported the value of $\tau$ was 215 ps for Ga$_2$O$_3$ similar to the material used here. This was faster than the lifetime of ~30 ns found in other studies [27]. This indicates that the ultrafast radiative recombination reported by Lee et al. [26] may differ from that found at longer delay times. The lifetime reported applies to non-equilibrium holes in n-type $\beta$-Ga$_2$O$_3$.

There are two types of turn-off power losses, namely turn-off losses in the diode and the switching losses induced by the diode turn-off during the MOSFET turn-on [28]. The latter value is shown in Table I, along with a comparison of peak reverse recovery current ($I_{RRM}$), $\tau_{rr}$ and recovery loss ($E_{rr}$) for previously reported Ga$_2$O$_3$ trench MOS Schottky diodes, Si-fast recovery diodes (FRDs, Rohm RF1005TF6S) and SiC Schottky barrier diodes from Cree (part number C3D0260A) [25] for turn-off from $I_F$ = 1 A. The $E_{rr}$ in our case is 1.52 uJ for diode turning-off only and around 18 uJ for total switching.
loss. For the Ga2O3 trench MOS-diode, the total switching loss is around 2 µJ. The main difference in these results is in the reverse voltage term on diode switching and reverse recovery charges $Q_{rr}$ term. The diode in this work has $Q_{rr}=30$ nC, while the trench MOS diode has $Q_{rr}=3.2$ nC, which is the area under the curve of the first negative current peak. Our rectifiers are more than an order of magnitude larger area than the trench diodes and show comparable $I_{RRM}$ and $E_{rr}$ to state-of-the-art SiC rectifiers.

These results demonstrate that Ga2O3 exhibits high speed switching characteristics. While the experimental values for blocking voltage are below the theoretical limits, continued developments in substrate defect reduction, epi-growth, device design, and fabrication processes will enhance its prospects for a role in power electronics. These results on large area rectifiers with high total current and an ability to operate in the >600V class range are another step in the advance of Ga2O3 for power electronics. Combined with the results from Takatsuka[25] on 1A, -100V trench MOS diode switching showing fast recovery from relatively large devices, these results confirm that Ga2O3 rectifiers are promising for power rectification applications. The immaturity, cost and limited variety are constrains for Ga2O3 being widely used in power switching applications. One possible solution to mitigate these issues might eventually be hybrid switches, a combination of Si MOSFETs and Ga2O3 rectifiers.

### III. SUMMARY AND CONCLUSION

β-Ga2O3 vertical Schottky rectifiers with an absolute forward current of >1 A and 760V breakdown voltage were demonstrated with large area (7.85 $\times$ 10$^{-3}$ cm$^2$). These devices were switched from 1 A to -300 V with $t_{on}$ of 64 ns, an important milestone towards the applications of Ga2O3 rectifiers in high power switching technologies. The initial thrust on Ga2O3 electronics is targeted towards high power converters for both DC/DC and DC/AC applications. Ga2O3 Schottky diodes could supplement 600V Si or SiC rectifiers targeted at switch mode power converters.

### REFERENCES


